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JUN 16 2004

OFFICE OF PETITIONS

In re Application of :
Dan Meisburger, Alan D. :
Brodie, Zhong-Wei Chen, Jack :
Y. Jau, Paul Sandland, Richard : DECISION GRANTING PETITION
Simmons, Dave E. A. Smith, : UNDER 37 CFR 1.47(a)
Hans Dohse, Dennis G. Emge, :
John Greene, Lee Veneklasen, :
Ming-Yie Ling, Surendra G. :
Lele and Kirkwood Rough :
Application No. 10/801,362 :
Filed: March 15, 2004 :
Title: INSPECTING OPTICAL :
MASKS WITH ELECTRON BEAM :
MICROSCOPY :

This is in response to the "Petition Under 37 CFR 1.47(a)," filed March 15, 2004.

The petition is granted.

Petitioner has shown that the non-signing inventor has refused to join in the filing of the above-identified application.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status. As provided in Rule 1.47(c), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the Declaration. Notice of the filing of this application will also be published in the Official Gazette.

The file is being forwarded to the office of Initial Patent Examination for further processing.

Telephone inquiries regarding this decision should be directed to the undersigned at (703) 306-9200.

A handwritten signature in dark ink, appearing to read 'E. J. Tannouse', with a long horizontal flourish extending to the right.

Edward J. Tannouse
Senior Petitions Attorney
Office of Petitions
United States Patent and Trademark Office



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In re Application of
Dan Meisburger, Alan D. Brodie, Zhong-Wei Chen, Jack Y. Jau, Paul
Sandland, Richard Simmons, Dave E. A. Smith, Hans Dohse, Dennis G.
Emge, John Greene, Lee Veneklasen, Ming-Yie Ling, Surendra G. Lele
and Kirkwood Rough
Application No. 10/801,362
Filed: March 15, 2004
For: INSPECTING OPTICAL MASKS WITH ELECTRON BEAM MICROSCOPY

Dear DAN MEISBURGER:

You are named as a joint inventor in the above identified United States patent application, filed under the provisions of 35 U.S.C. 116 (United States Code), and 37 CFR 1.47(a), Rules of Practice in Patent Cases. Should a patent be granted on the application you will be designated therein as a joint inventor.

As a named inventor you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent attorney or agent presenting written authorization from you. If you care to join the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

Telephone inquiries regarding this communication should be directed to Petitions Attorney Edward Tannouse at (703) 306-9200. Requests for information regarding your application should be directed to the File Information Unit at (703) 308-2733. Information regarding how to pay for and order a copy of the application, or a specific paper in the application, should be directed to Certification Division at (703) 308-9726 or 1(800) 972-6382 (outside the Washington D.C. area).

Edward J. Tannouse
Petitions Attorney
Office of Petitions
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